General Specifications

Model TDLS8000 Tunable Diode Laser Spectrometer

GS 11Y01D01-01EN

Overview

Yokogawa's new TDLS8000 houses all of the industry's leading features in one robust device. The platform design is for in situ measurements which negate the need for sample extraction and conditioning.

The non-contacting sensor allows for a variety of process types including corrosive, abrasive and condensing.

The first generation platform has been proven in many others for the measurements of O_2 , CO, CH_4 , NH_3 , H_2O and many more NIR absorbing gases.

This second generation platform has improved reliability and ease of installation and maintenance while still meeting or exceeding designed application demands.



TDLS8000 with YH8000 HMI Unit

■ Features

SIL2, TruePeak combined with smart laser technology

- Measurement integrates the area of the absorbance and gets a true, interference-free analysis under changing pressure, temperature and background
- Laser module is replaceable on site without any calibration or adjustment
- Internal reference cell in the laser module ensures peak locking during trace measurement
- Laser and Detector modules are sealed to protect them from dirty purge gas
- On board diagnostics and low TCO(*1) (no moving parts, high MTTF(*2) for components)
- IEC61508 SIL designed & approved, SIL 2 capability for single analyzer use, SIL 3 capability for dual analyzer use

• Intuitive touchscreen HMI

- Large HMI provides easy operation and control of up to 4 analyzers at the same time·A standard mini display at both sides enables easy optical alignment
- HART and Modbus TCP communications standard
- 8-stage auto-gain adapts to difficult applications
- Auto-gain enables wide signal ranges against dynamic variation of transmission.
- Fully field repairable with 50 days of data and spectra storage
- Compact design for one-man installation without sacrificing ruggedness
- IECEx, ATEX, cFMus hazardous area approvals based on Nonincendive/Type n and explosionproof.
- Purge gas is no need for Explosionproof.
- In-situ or extractive analysis and fast response (2-5 seconds, 1 second (optional))
- Process pressures up to 1 MPa and process temperatures up to 1,500°C (Note)

Note: Maximum process temperatures and pressures will vary by application

- *1: Total Cost of Ownership
- *2: Mean Time To Failure

Typical gases measured include:

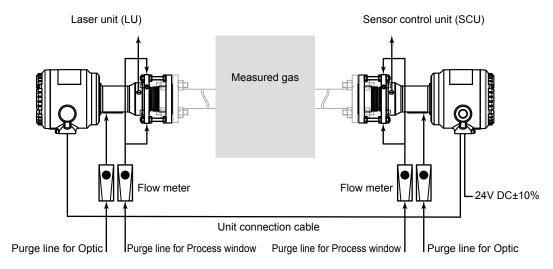
- Oxygen in process and combustion applications. Process temperatures can be as high as 1,500°C, and process pressures can be as high as 1 MPa. Measurement span is typically between 1% and 25% oxygen.
- Carbon monoxide in process and combustion applications. Process temperatures can be as high as 1,500°C. Two versions are available, high sensitivity with ppm detection limits, and standard sensitivity for higher ppm and percent level CO measurement
- Moisture in corrosive and aggressive process streams. Measurement down to the sub-ppm level is available for some applications

Other applications and gas measurements are possible with the TDLS8000. Please fill out the Application Data Sheet at the end of this document and send to Yokogawa.

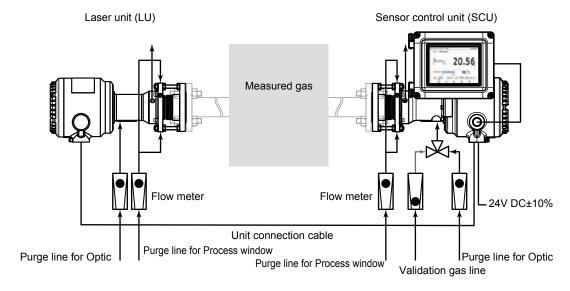


■ System configuration

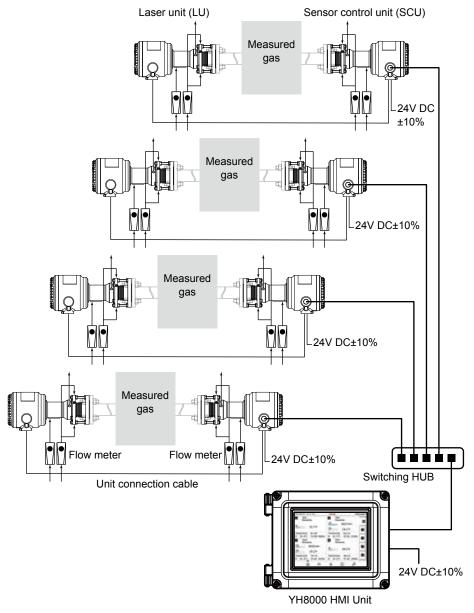
Standard System Configuration



System Configuration with YH8000 HMI Unit and Validation gas line



Multi Analyzer Configuration with Remote HMI



Note: If power supply is 100 to 240 V AC, purchase the Universal Power Supply, separately.

If four multi analyzer configuration with remote HMI is made, five universal power supply including YH8000 are needed.

■ STANDARD SPECIFICATIONS

TDLS8000 Tunable Diode Laser Spectrometer

Measurement object:

O₂, CO (+CH₄), H₂O, NH₃ (+H₂O) concentration in combustion exhaust gas and process gas

If CO₂, H₂S, or other gas measurements are required, consult with Yokogawa

Measurement system:

Tunable diode laser spectroscopy Light source; Near-infrared tunable diode laser Measured components and ranges:

Measured c	omponent	Min. range	Max. range		
O ₂		0-1%	0-25%		
CO(ppm)		0-200 ppm 0-10000 p			
00.011	СО	0-200 ppm	0-10000 ppm		
CO+CH ₄	CH ₄	0-	5%		
NH ₃		0-30 ppm	0-5000 ppm		
H ₂ O(ppm) in	non HC (*1)	0-30 ppm 0-30000 p			
H ₂ O(ppm) in	HC (*2)	0-30 ppm 0-30000 p			

*1: Non hydrocarbon background.

*2. Hydrocarbon background

Please consult with Yokogawa if the measuring range for your sample gas is outside of the above ranges Optical path length:

> Optical distance between the laser unit and the sensor control unit

Standard; 0.5 to 6 m (Application dependent) Max: 30 m (With optional Large Aperture

Optics (LAO))

Note: If your optical path length is under 0.5 m or over 30 m, please consult with Yokogawa.

Safety and EMC conforming standards:

Safety Conforming Standards:

EN61010-1, EN61010-2-030 CE UL UL61010-1, UL 61010-2-030 CAN/CSA-C22.2 No.61010-1, CAN/ **CSA** CSA-C22.2 No.61010-2-030

GB30439 Part 1

2000 m or less Installation altitude:

Installation category:

(Anticipated transient overvoltage 330V)

Measuring category: O (Other)

Pollution degree: 2, Indoor/Outdoor use

Note: Installation category, called overvoltage category, specifies impulse withstand voltage. Pollution degree indicates the degree of existence of solid, liquid, gas or other inclusions which may reduce dielectric strength.

EMC Conforming Standards:

EN55011 Class A Group 1

EN61326-1 Class A Table 2 (For use in

industrial location), EN61326-2-3

RCM EN55011 Class A Group 1

KC KN11 Class A Group 1, KN61000-6-2 (Korea Electromagnetic Conformity)

Laser classification; CSA E60825-1, CE

EN60825-1, FDA 21CFR part 1040.10

Class 1 laser product

SIL Certification:

IEC 61508:Functional safety of Electrical/ electronic/programmable electronic related systems; SIL 2 capability for single analyzer use, SIL 3 capability for dual analyzer use.

Display: 128 x 64 dots LCD; On Sensor Control Unit Status LEDs: 3 on Sensor Control Unit (Green:

Power, Orange: DO, Red: Fault) 4 digit 7-segment LEDs: On Laser Unit

Display items:

LCD on Sensor Control Unit; Gas concentration, Transmission, Process gas temperature (AI), Process gas pressure (AI), System status, Alarm information, System information (Product serial no., Laser module serial no., Output signal, IP address, HART address, Optical path length, Analyzer internal temperature)

7-segment LEDs on Laser Unit; Transmission Analog output: 2 points, 4 to 20 mA DC (Isolated from the power supply and ground, Max. load resistance 550 Ω)

Output types; Gas concentration, Transmission, Process gas temperature, Process

gas pressure Output range; 3.0 to 21.6 mA DC

Digital communications:

HART: On analog output signal 1 (AO-1) Load resistance; 250 to 550 Ω (Include cable resistance)

RJ-45 connector in Sensor Control Unit Ethernet;

Protocol; Modbus/TCP

Communication speed; 100 Mbps

Digital output: 2 points, contact rating 24V DC, 1A

Function: Activate during Warning / Calibration / Validation / Warm up / Maintenance conditions

Contact Specification: Relay contact output (Isolated from the power supply and ground), C-contact (NC/NO/COM)

Fault:

Function: Activate during Fault condition or when

the system power is off

Contact Specification: Relay contact output (Isolated from the power supply and

ground), A-contact (NC/COM)

Valve control output: 2 points

Function; Activate calibration or validation solenoid valves for zero, span or validation gas.

Output signal; 24V DC, 500 mA Max. per terminal Alarm:

Warning:

Fault;

Gas concentration low, Gas concentration high, Transmission low, Process pressure low. Process pressure high. Process temperature low, Process temperature high, Validation required, Validation failure, Zero calibration error, Span calibration error, Non process alarm,

External alarm

Laser module temperature low, Laser module temperature high, Laser temperature low, Laser temperature high, Detector signal high, Peak center out of range, Reference peak height low, Absorption too high, Transmission lost, Reference transmission low, Reference peak height high, Laser unit failure, Laser

module error, File access error, E2PROM

access error

20 g/m³ or less Digital input: 2 points Dust in process gas; Function: External Alarm/Calibration start/ (Dust loading levels are dependent Validation start/Stream switch (Valve upon the application, OPL and other installation factors) control) Contact specification; Zero voltage contact input Warm-up time: 5 min. (Isolated from the power supply and Installation condition: ground) Ambient operating temperature; -20 to 55°C Input signal; Open signal: 100 $k\Omega$ or more, Close Storage temperature; -30 to 70°C Humidity; 0 to 95%RH at 40°C (Non-condensing) signal: 200 Ω or less Analog input: 2 points Mounting flange type; ASME B16.5, DIN, JIS 4 to 20 mA DC (Isolated from Signal type; Cable entries: the power supply and Ground), with Sensor Control Unit: 1/2NPT or M20x1.5mm,one hole 3/4NPT or M25x1.5mm, three holes selectable powered/unpowered function Laser Unit: 3/4 NPT or M25x1.5mm, one hole Input signal range; 2.4 to 21.6 mA DC Process gas temperature, Process Purge gas connections; Input types; gas pressure 1/4NPT or Rc1/4 Self-diagnostics: If other gas connections are required, Laser Unit temperature, Sensor Control please consult with Yokogawa. Unit temperature, Laser temperature, Purge gas; Theoretically, instrument air could be Detector signal level, Memory read/write used as a purge gas for all of the below function, Peak locking condition applications except for oxygen or H2O Calibration: measurement. Choosing between using Calibration method; Zero/Span calibration nitrogen or instrument air or purge gas will Calibration mode; Manual, Auto (Time initiate, ultimately depend upon further application Remote initiate (DI/Modbus)), Semi-Auto details and the desired precision of the measurement. All gasses should be clean (YH8000/HART) Validation: and dry. Validation method; Up to 2 points Recommended purge gasses: Validation mode; Manual, Auto (Time initiated, O_2 analyzer: N_2 (99.99% or greater, application Remote initiate (DI/Modbus)), Semi-Auto dependent) H₂O ppm analyzer: (YH8000/HART) N₂ (99.99% or greater with Power supply: 24V DC +/-10% < 20 ppm H₂O for feed to the optional If your power supply is 100 to 240 V AC, dryer package) N₂ (99.99% or greater, Universal Power Supply, M1276WW (sold CO, NH₃ analyzer: application dependent) or Instrument air separately), is required Purge gas flow rates; 2 to 20 L/min for optic Power consumption: Max. 20W; TDLS8000 only 5 to 300 L/min for process window Max. 60W; TDLS8000 with YH8000 and 2 solenoid (Application dependent) valves Protection degree: IP66, NEMA Type 4X Hazardous area classifications: Material: Case; A356.0 aluminum alloy Division 1, Zone 1: Explosionproof TDLS8000-D1 (FM) Wetted materials: 316 SS, BK-7 glass, Teflon encapsulated FKM (o-ring for alignment flange), Silicone Division system: Type of protection: Explosionproof for Class I, (o-ring for LAO) Division 1, Groups A, B, C, Paint color: Mint green (RAL 190 30 15 or equivalent) Weight: **Dust-Ignitionproof for Class** Sensor Control Unit; 8 kg Laser Unit: II/III, Division 1, Groups E, 8 kg F, G, T5 Large Aperture Optics: 14 kg ANSI Class 150-2-RF (Eq.) Alignment Flange; 5 kg/pc Enclosure rating: NEMA Type4X ANSI Class 150-3-RF (Eq.) Alignment Flange; 7 kg/pc ANSI Class 150-4-RF (Eq.) Alignment Flange; 9 kg/pc Applicable standards: Class 3600 2011, Class 3615 2006,Class 3616 2011, Class 3810 DIN PN16-DN50-A (Eq.) Alignment Flange; 5 kg/pc DIN PN16-DN80-A (Eq.) Alignment Flange; 6 kg/pc 2005, NEMA 250 2003 JIS 10K-50-FF (Eq.) Alignment Flange; 5 kg/pc
JIS 10K-80-FF (Eq.) Alignment Flange; 6 kg/pc
Flow Cell Alignment Flange; 5 kg/pc Zone system: Type of protection: Class I, Zone 1, AEx d IIC T5 Zone 21, AEx tb IIIC T100°C Process gas condition: Enclosure rating: **IP66** Process gas temperature; Max. 1,500°C, Applicable standards: Application dependent ANSI/ISA-60079-0 (12.00.01)-2013, Process gas pressure; Max.1 MPa, Min. 90 kPa, ANSI/ISA-60079-1 (12.22.01)-Application dependent 2009 (R2013), ANSI/ISA-60079-31 Note: When using TDLS8000 as CE marking compliance (12.10.03)-2013, ANSI/IEC 60529 product, the upper limit of the measurement gas 2004 (R2011) pressure is 50kPa in gauge pressure.

TDLS8000-C1 (cFM) Type of protection: Ex d IIC T5 Class II/III, Division 1, Groups E, F, G Enclosure rating: IP66, Type4X Applicable standards: C22.2 No.0-10, CAN/CSA-C22.2 No.04-04 (2013), C22.2 No.25-1966 (R2014), C22.2 No.94.1-07 (R2012), C22.2 No.94.2-07 (R2012), CAN/ CSA-C22.2 No.60079-0: 11, CAN/ CSA-C22.2 No.60079-1: 11, CAN/ CSA-C22.2 No.60079-31: 12, CAN/ CSA-C22.2 No.60529-05 (R2010) TDLS8000-S1 (ATEX) Type of protection: II 2(1) G Ex d [op is T6 Ga] IIC T5 Gb II 2 D Ex tb IIIC T100°C Db Enclosure rating: IP66 Applicable standards: EN 60079-0:2012 /A11:2013, EN 60079-1 2007, EN 60079-28 2007, EN 60079-31 2014, EN 60529:1991/A2 2013 TDLS8000-E1 (IECEx) Type of protection: Ex d [op is T6 Ga] IIC T5 Gb Ex tb IIIC T100°C Db Enclosure rating: IP66 Applicable standards: IEC 60079-0 2011, IEC 60079-1 2007, IEC 60079-28 2006, IEC 60079-31 2013, IEC 60529 2013 Division 2, Zone 2: Non-Incendive/Type n TDLS8000-D2 (FM) Division system: Type of protection: Non-Incendive for Class I, Division 2, Groups A, B, C, **Dust-Ignitionproof for Class** II/III, Division 1, Groups E, F, G, T5 Enclosure rating: NEMA Type 4X Applicable standards: Class 3600: 2011, Class 3611: 2004, Class 3616: 2011, Class 3819: 2005 NEMA 250: 2003 Zone system: Type of protection: Class I, Zone 2, AEx nA nC IIC T5 Zone 21, AEx tb IIIC T100°C **Enclosure Rating:** Applicable standards: ANSI/ISA-60079-0-2013, ANSI/ISA-60079-15-2012, ANSI/ISA-60079-31-2013, ANSI/IEC 60529-2004 (R2011) TDLS8000-C2 (cFM) Type of protection: Ex nA nC IIC T5 Class II/III, Div 1, Groups E, F, G IP66, Type 4X Enclosure rating: Applicable standards: C22.2 No.0-10, CAN/CSA-C22.2 No.04-04 (2013), C22.2 No.25-1966 (R2014), C22.2 No.94.1-07 (R2012), C22.2 No.94.2-07 (R2012), CAN/

TDLS8000-S2 (ATEX)

Type of protection: II 3(1) G Ex nA nC [op is T6

Gaì IÍC T5 Gc

II 2 D Ex tb IIIC T100 °C Db

Enclosure rating: **IP66** Applicable standards:

EN 60079-0: 2012/A12:2013, EN 60079-15: 2010, EN 60079-28: 2007, EN 60079-31: 2014, EN 60529: 1991/

TDLS8000-E2 (IECEx)

Type of protection: Ex nA nC [op is T6 Ga] IIC

T5 Gc

Ex tb IIIC T100°C Db

Enclosure rating:

Applicable standards:

IEC 60079-0: 2011, IEC 60079-15: 2010, IEC 60079-28: 2006, IEC 60079-31: 2013, IEC 60529: 2013

PERFORMANCE

Repeatability / Linearity:

Measure	d gas	Repeatability	Linearity
O ₂		+/- 1% reading or +/- 0.01 %O ₂ , whichever is greater	+/- 1% F.S.
CO (ppm)		+/- 2% reading or +/- 1 ppm CO, whichever is greater	+/- 1% F.S.
CO+	со	+/- 2% reading or +/- 1 ppm CO, whichever is greater	+/- 2% F.S.
CH ₄	CH ₄	+/- 4% reading or +/- 0.02% CH ₄ , whichever is greater	+/- 4% F.S.
NH3		+/- 2% reading or +/- 1 ppm NH ₃ , whichever is greater	+/- 2% F.S.
H ₂ O (ppm) in non HC		+/- 2% reading or +/- 0.1 ppm H ₂ O, whichever is greater	+/- 1% F.S.
H ₂ O (ppm HC	n) in	+/- 2% reading or +/- 0.1 ppm H ₂ O, whichever is greater	+/- 1% F.S.

Measurement conditions: Gas temperature; 25°C, Gas pressure; 0.1 MPa, Optical path length; 1 m

Data Update Cycle:

Standard; Approx. 2 seconds (Response time may increase for non-standard applications)

If 2 seconds response is required, please

consult with Yokogawa

Zero Drift: Typically <0.1% of the minimum range

over 24 months

Influences on the Measurement - Application dependent

- A. Temperature: The temperature of the measured gas should be taken into account by the analyzer so that the reading can be corrected on a real time basis. The effect is specific to each different measurement gas.
 - a. If the gas temperature is constant at the desired measurement condition, then a fixed gas temperature may be programmed into the analyzer. This fixed value can be used in real time by the analyzer to provide a temperaturecompensated reading.
 - b. If the gas temperature is relatively equal to the ambient temperature, then an integral sensor value may be utilized by the analyzer. This active ambient value is used real time by the analyzer to provide a temperature compensated reading.

CSA-C22.2 No.60079-0:11, CAN/

CSA-C22.2 No.60079-15:12, CAN/

CSA-C22.2 No.61010-1-12, CAN/

CSA-C22.2 No.60529-05 (R2010)

- c. If the gas temperature is variable, then an external sensor value may be utilized by the analyzer. This active input value can be used in real time by the analyzer to provide a temperature compensated reading.
- B. Pressure: The pressure of the measured gas must be taken into account by the analyzer so that the reading can be corrected on a real time basis. The effect is specific to each different measurement
 - a. If the gas pressure is constant at the desired measurement condition, then a fixed gas pressure may be programmed to the analyzer. This fixed value can be used in real time by the analyzer to provide a pressure compensated reading.
 - b. If the gas pressure is variable, then an external sensor value may be utilized by the analyzer. This active input value can be used in real time by the analyzer to provide a pressure compensated reading.

YH8000 HMI Unit

The YH8000 is an HMI designed specifically for the TDLS8000. The YH8000 features an easy-to-use touchscreen 7.5 inch color LCD which can be used to display maintenance information, display alarm statuses and records, and set all parameters of the TDLS8000.

The YH8000 can be installed directly on the TDLS8000 or installed remotely.

An Ethernet connection is used to connect the YH8000 to up to four TDLS8000s simultaneously via a hub.

Touchscreen 7.5 inch TFT color LCD Display:

panel, 640 x 480 (VGA)

Communication: Ethernet; RJ-45 connector

Communication speed; 100 Mbps

Case: Aluminum alloy

Paint color: Mint green (RAL 190 30 15 or equivalent) Protection degree of enclosure: IP65, NEMA Type 4X

Window: Polycarbonate

Weight: 4 kg

Mounting: Analyzer mount (Front, left-side, right-side)

with tilt function, Pipe mount, or Panel

mount (Stainless steel)

Cable Entries: 1/2NPT or M20x1.5 mm, two holes

Installation conditions:

Ambient operating temperature; -20 to 55°C -30 to 70°C Storage temperature: Humidity: 10 to 90%RH at 40°C (Non-condensing)

Power Supply: 24V DC +/-10% Power consumption: Max.12 W Safety and EMC conforming standards:

Safety Conforming Standards:

EN61010-1 CE UL UL61010-1

CAN/CSA-C22.2 No.61010-1 CSA

GB GB30439 Part 1 Installation Altitude: 2000 m or less

Installation category:

(Anticipated transient overvoltage 330 V)

Pollution dearee: Indoor/Outdoor use **EMC Conformity Standards:**

EN55011 Class A Group 1

EN61326-1 Class A Table 2 (For use in

industrial location)

EN55011 Class A Group 1 **RCM**

KN11 Class A Group 1, KN61000-6-2 KC

(Korea Electromagnetic Conformity)

Hazardous area classifications:

Division 2, Zone2: Non-Incendive/Type n

YH8000-D2 (FM)

Division system

Type of protection: Non-Incendive for Class I, Division 2, Groups A, B, C, D, T5

NEMA Type 4X

Enclosure rating: Applicable standards: Class 3600: 2011, Class

3611: 2004, Class 3810:

2005, NEMA 250: 2003

Zone system

Type of protection: Class I, Zone 2, AEx nA ic

IIC T5

Enclosure rating: IP65

ANSI/ISA-60079-0-2013, Applicable standards:

ANSI/ISA-60079-11-2014, ANSI/ISA-60079-15-2012, ANSI/IEC 60529-2004

(R2011)

YH8000-C2 (cFM)

Type of protection: Ex nA nL IIC T5 Enclosure rating: Applicable standards:

IP65, Type 4X C22.2 No. 0-10, CAN/ CSA-C22.2 No. 04-04 (R2013), C22.2 No. 94.1-07 (R2012), C22.2 No. 94.2-07 (R2012), CAN/CSA-C22.2 No.60079-0:11, CAN/ CSA-C22.2 No.60079-15:12, CAN/CSA-C22.2 No.61010-1-12 CAN/CSA-C22.2 No.

60529-05 (R2010)

YH8000-S2 (ATEX)

Type of protection: II 3 G Ex nA ic IIC T5 Gc

Enclosure rating: **IP65**

EN 60079-0: 2012/ Applicable standards:

A12:2013, EN 60079-11: 2012, EN 60079-15: 2010, EN 60529: 1991/A2:2013

YH8000-E2 (IECEx)

Type of protection: Ex nA ic IIC T5 Gc

IP65 Enclosure rating:

IEC 60079-0: 2011, IEC Applicable standards:

60079-11: 2011, IEC 60079-15: 2010, IEC 60529: 2013

IF8000 Isolation Flanges

A process isolation flange protects the TDLS8000 from the process gas pressure and the heat, dust, and corrosive elements of the process gas. A process isolation flange must be installed in the following situations.

- When the process gas pressure exceeds 500 kPa
- When the process temperature is high and the temperature of the process window area exceeds 55°C even when process window purge is performed.
- When the process dust level is high and the adherence of dust or intrusion of corrosive elements cannot be prevented even when process window purge is performed.

The IF8000 isolation flanges can be used for additional protection in in-situ or bypass installations.

Note: Must use in conjunction with alignment flanges Process connections: (see below table) Measured gas temperature: 200°C max Measured gas pressure: Less than 1 MPa

Wetted materials: Sapphire, 316 SS, Monel 400,

Kalrez (O-ring)

Weight;

Process	Analyzer	Wei	ight	
connection	connection	316SS	Monel 400	
ANSI Class 150- 2-RF Flange		5 kg/pc	6 kg/pc	
ANSI Class 300- 2-RF Flange		7 kg/pc	7 kg/pc	
ANSI Class 150- 3-RF Flange	ANSI Class 150- 2-RF Flange	8 kg/pc	9 kg/pc	
ANSI Class 300- 3-RF Flange		11 kg/pc	12 kg/pc	
ANSI Class 150- 4-RF Flange		12 kg/pc	14 kg/pc	
DIN PN16-DN50 Flange		7 kg/pc	7 kg/pc	
DIN PN16-DN80 Flange	DIN PN16-DN50	10 kg/pc	11 kg/pc	
JIS 10K-50-FF Flange	Flange	7 kg/pc	7 kg/pc	
JIS 10K-80-FF Flange		9 kg/pc	10 kg/pc	

Note: When using TDLS8000 as CE marking compliance product, the upper limit of the measurement gas pressure is 50kPa in gauge pressure.

YC8000 Flow Cell

Used for extracting sample streams at any location.

Note: Must use in conjunction with alignment flanges ("-FC")

Gas temperature: 200°C max
Gas pressure: less than 1.3 MPa

Wetted materials: Sapphire, 316 SS, Monel 400,

Kalrez (O-ring)

Weight;

Material/Optical Path Length	1016 mm (40 inch)	1524 mm (60 inch)
Monel 400	15 kg	18 kg
316 SS	14 kg	17 kg

Note: When using TDLS8000 as CE marking compliance product, the upper limit of the measurement gas pressure in YC8000 is 50kPa in gauge pressure.

Calibration Cell

Used for off-line calibrations and validations. Appropriate process windows are included on calibration cell.

Optical Path Length: 660 mm Material: 316 SS

Part No.	Description	Weight
K9772XA	Calibration Cell with free-standing frame for O ₂	
K9772XB	Calibration Cell with free-standing frame for O ₂ LAO	
K9772XC	Calibration Cell with free-standing frame for ppm H ₂ O in non-hydrocarbon background	
K9772XD	Calibration Cell with free-standing frame for NH ₃	14 kg
K9772XE	Calibration Cell with free-standing frame for ppm H ₂ O in hydrocarbon	
K9772XF	Calibration Cell with free-standing frame for ppm CO	
K9772XG	Calibration Cell with free-standing frame for ppm H ₂ O LAO	

Note: When using TDLS8000 as CE marking compliance product, the upper limit of gas pressure in calibration cell is 50kPa in gauge pressure.

Unit Connection Cable

Use for interconnecting the Sensor Control Unit and the Laser Unit.

Construction:Double-shielded (Overall shield and Individual shields) 4-pair cable

Part No.	Cable length
K9775WA	5 m
K9775WB	10 m
K9775WC	20 m
K9775WD	30 m
K9775WE	40 m
K9775WF	50 m
K9775WG	60 m

■ MODEL AND CODES

TDLS8000 Tunable Diode Laser Spectrometer

Model		Suf	fix (Cod	e		Option Code	Description				
TDLS8000								Tunable Diode Laser Spectrometer				
Туре	-G1 -G2 -D2 -C2 -S2 -E2 -J2							General Purpose, cable entry/piping:NPT General Purpose, cable entry:Metric thread, piping:Rc FM Class I Div 2, Zone2, cable entry/piping:NPT (*9) cFM Class I Zone2, cable entry/piping:NPT (*9) ATEX CAT 3/ Zone 2, cable entry:Metric thread, piping:Rc (*9) IEC-Ex / Zone2, cable entry:Metric thread, piping:Rc (*9) TIIS Ex / Zone 2, cable entry:Metric thread, piping:Rc (*9) FM Class I Div 1, Zone1, cable entry/piping:NPT (*9)				
	-C1 -S1 -E1 -J1	-E1						cFM Class I Zone1, cable entry/piping:NPT (*9) ATEX CAT 2/ Zone 1, cable entry:Metric thread, piping:Rc (*9) IEC-Ex / Zone1, cable entry:Metric thread, piping:Rc (*9) TIIS Ex / Zone 1, cable entry:Metric thread, piping:Rc (*9)				
Gas Parameter -X1 -X2 -C3 -C4 -A1 -H1 -H3							Oxygen < 600°C, 0-25% Oxygen < 1500°C, 0-25% Combustion Carbon Monoxide ppm <1500°C Combustion CO ppm <1500°C + CH ₄ 0-5% Combustion Ammonia up to 0-5,000ppm DeNO _X <450°C (*3) H ₂ O ppm non-Hydrocarbon Background (*1) H ₂ O ppm Hydrocarbon Background (*1)					
Optics Accessory -NN -LA -U2 -U3 -U4 -D5 -D8 -J5 -J8 -FC							Without Alignment Flanges (*2) Large Aperture Optics, ANSI CLASS150-4-RF (*3) (*4) (*8) ANSI CLASS150-2-RF(Eq.) Alignment Flange, pipng: NPT ANSI CLASS150-3-RF(Eq.) Alignment Flange, pipng: NPT ANSI CLASS150-4-RF(Eq.) Alignment Flange, pipng: NPT DIN PN16-DN50-D(Eq.) Alignment Flange, pipng: Rc DIN PN16-DN80-D(Eq.) Alignment Flange, pipng: Rc JIS 10K-50-FF(Eq.) Alignment Flange, pipng: Rc JIS 10K-80-FF(Eq.) Alignment Flange, pipng: Rc Flow Cell Alignment Flange (*4)					
I/O Interface				-A1				Analog with HART+Modbus Ethernet				
SI Unit -J				Only SI Unit SI Unit or non SI Unit								
Option -N			-N	/D /RX /RC /SCT	Always -N Diverging Beam without LAO (*5) Reference Cell for O ₂ (*6) Reference Cell for CO (*7) Stainless Steel Tag Plate							

- When "-H1" or "-H3" is selected, TIIS Zone1 is not available.
- *2: When "-NN" is selected, Zone2/Div2 is not available.
- When "-LA" is selected, Zone1/Div1 is not available.
- When FM or cFM explosionproof type is specified, the connecting port for window purge is 1/4NPT. When ATEX, IEC-Ex or TIIS explosionproof type is specified, the connecting port for window purge is Rc1/4.

 The Option "/D" can be selected when Large Aperture Optics "-LA" of the Option Accessory is not specified.

 The Option "/RX" can be used when Oxygen analyzer is selected. When both "-X2" of the Gas Parameter and "-LA" of the
- *6: Optics Accessory are selected, "/RX"must be specified.
 The Option "/RC" can be used when CO analyzer is selected. When both "-C3" or "-C4" of the Gas Parameter is selected,
- "/RC" must be specified.
- *8: For applications whose optical path length is 6 m or longer, select the "-LA". A condensing lens unit (LAO unit) is added to the SCU side.
- Pending.

YH8000 HMI Unit

Model	Suffi	ix C	ode	Option Code	Description						
YH8000											HMI Interface Unit
Туре	-G1 -G2 -D2 -C2 -S2 -E2 -J2		G2		General Purpose, NPT thread for cable entry General Purpose, Metric thread for cable entry FM Class I Div 2, Zone2, NPT thread for cable entry (*1) cFM Class I Zone2, NPT thread for cable entry (*1) ATEX CAT 3/ Zone 2, Metric thread for cable entry (*1) IEC-Ex / Zone2, Metric thread for cable entry (*1) TIIS Ex / Zone 2, Metric thread for cable entry (*1)						
Language		-E			English						
_			-N		Always -N						
Option				/M /P /W /S /C /SCT	Mounting kit for TDLS8000 Pipe mount Wall mount Sun Shield Local HMI connection cable: 3m Stainless Steel Tag Plate						

^{*1:} Pending.

IF8000 Isolation Flanges

Model		Su	ffix Co	de		Option Code	Description		
IF8000							Isolation Flange for TDLS8000 (2pcs/unit) (*1)		
Process	-21						ANSI CLASS150-2-RF(Eq.)		
Connection	-23						ANSI CLASS300-2-RF(Eq.)		
(*2)	-31						ANSI CLASS150-3-RF(Eq.)		
	-33						ANSI CLASS300-3-RF(Eq.)		
	-41						ANSI CLASS150-4-RF(Eq.)		
	-50						DIN PN16-DN50-D(Eq.)		
	-80						DIN PN16-DN80-D(Eq.)		
	-J5						JIS 10K-50-FF(Eq.)		
	-J8	J8 JIS 10K-80-FF(Eq.)							
Analyzer Conn	ection	-21					ANSI CLASS150-2-RF(Eq.)		
(*3)		-50					DIN PN16-DN50-D(Eq.)		
Material		-	-MN				Monel 400		
			-SS				316/316L SS		
Sapphire Wind	ow Typ	е		-11			Uncoated		
				-12			Coated for O ₂		
	-13					Coated for ppmH ₂ O non Hydrocarbon background			
-14							Coated for ppmNH ₃		
-15					Coated for ppmH ₂ O Hydrocarbon background				
				-16			Coated for ppmCO		
_					-N		Always -N		

IF8000 is delivered with two sets (for LU and SCU).

YC8000 Flow Cell

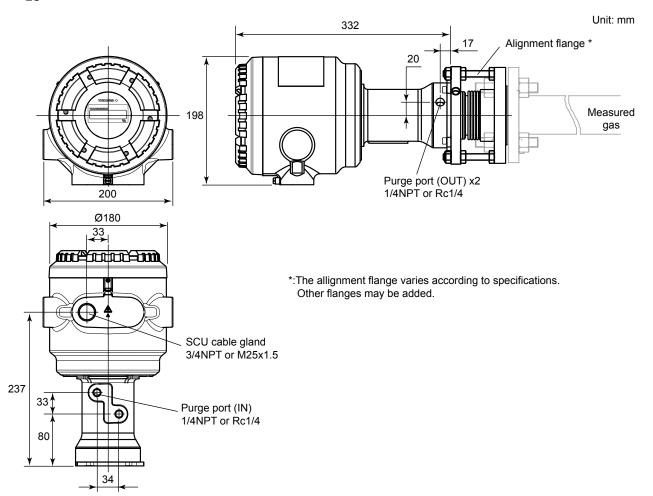
Model			Su	ffix Co	de			Option Code	Description			
YC8000									Flow Cell for TDLS8000			
Flow Cell Type	-EN								Enhanced			
Optical Path Length -40 -60							Forty Inches Sixty Inches					
Material -MN -SS								Monel 400 316/316L SS				
Port Configurati	on			-3					3 ports			
Window Type					-UC -XX -H3 -HH				Uncoated Oxygen Moisture Hydrocarbon background Moisture non Hydrocarbon background			
Inside Wall Treatment -NN -EP						1						
							-N		Always -N			

When ANSI flange of the Process Connection is selected, the "-21" of Analyzer Connection must be specified. When DIN or JIS of the Process Connection is selected, the "-50" of Analyzer Connection must be specified. The Analyzer Connection must be selected according to the flange size of TDLS8000.

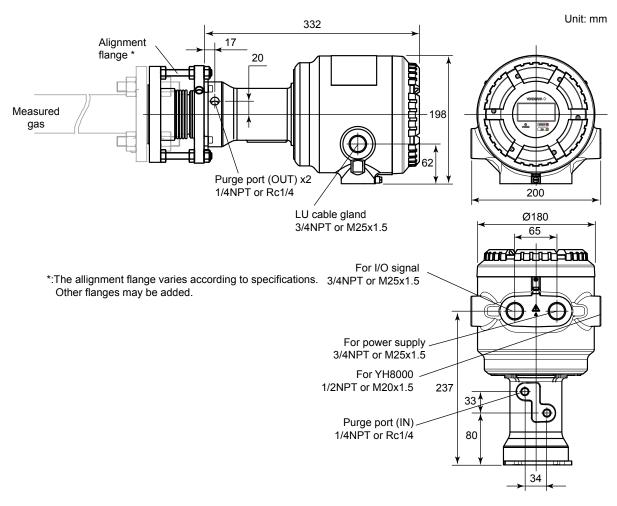
■ EXTERNAL DIMENSIONS

TDLS8000 with Alignment Flange

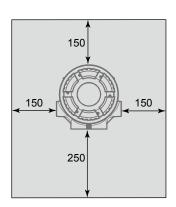
• LU

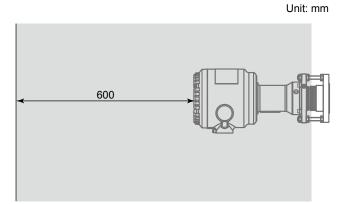


• SCU

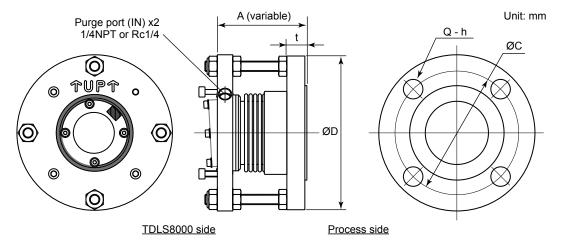


• Maintenance space



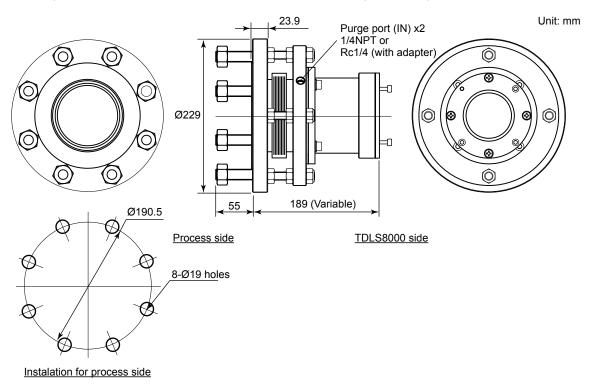


Alignment Flange

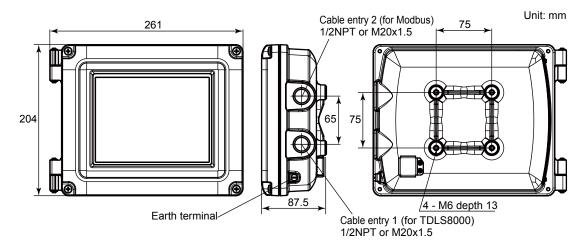


Optics Accessory code (flange)	Hole QTY Q	Hole h	Hole P.C.D C	Thickness t	Outside dia. D	Distance A	Purge port
-U2 ANSI CLASS150-2-RF(Eq.)	4	19	120.7	19.5	150	87	1/4NPT
-U3 ANSI CLASS150-3-RF(Eq.)	4	19	127	24.3	190	92	1/4NPT
-U4 ANSI CLASS150-4-RF(Eq.)	8	19	152.4	23.9	228.6	92	1/4NPT
-D5 DIN PN16-DN50-D(Eq.)	4	18	168.3	18	165	86	Rc1/4
-D8 DIN PN16-DN80-D(Eq.)	8	18	190.5	20	200	88	Rc1/4
-J5 JIS 10K-50-FF(Eq.)	4	19	125	16	155	84	Rc1/4
-J8 JIS 10K-80-FF(Ea.)	8	19	160	18	185	86	Rc1/4

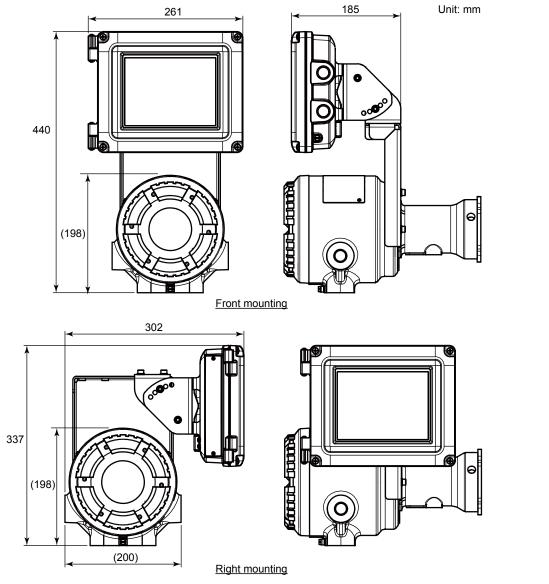
• LAO (Large Aperture Optics); Optics Accessory code "-LA"
This accessory is only for SCU side. For LU side, the Alignment flange ANSI CLASS150-4-RF (Eq.) will be mounted. When piping is Rc1/4, a conversion adopter will be attached on the Alignment flange of the LU side.



■ YH8000 HMI Unit

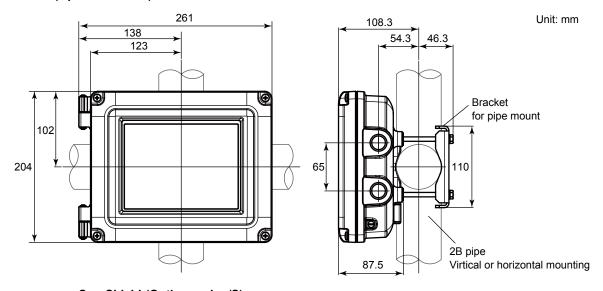


Mounting kit for TDLS8000 (Option code: /M)

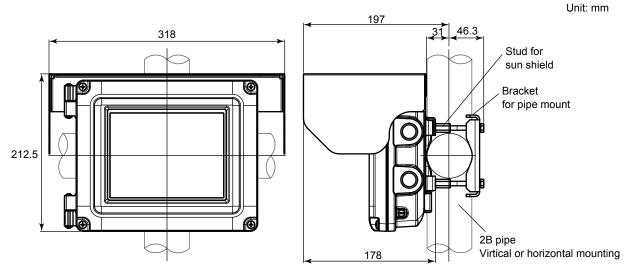


Available for left mounting

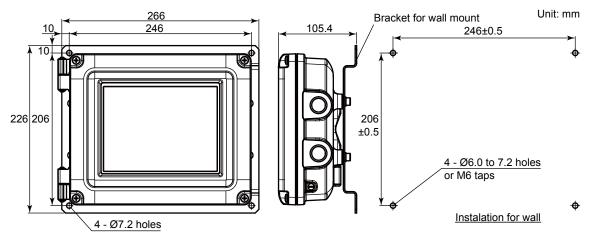
Pipe mount (Option code: /P)



Sun Shield (Option code: /S)

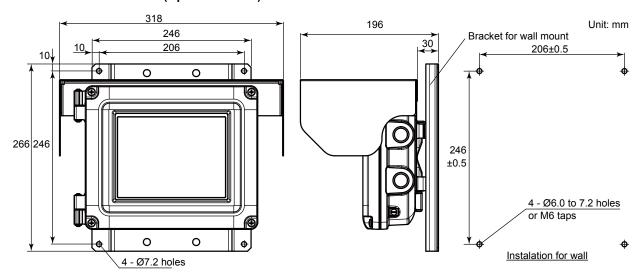


Wall mount (Option code: /W)



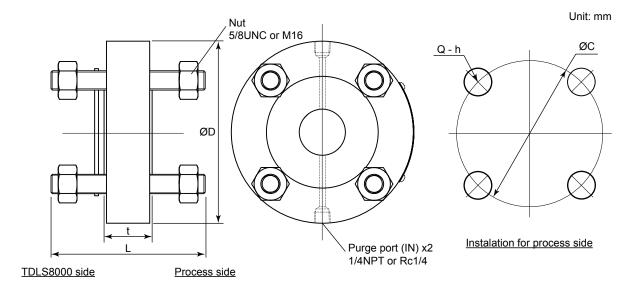
^{*:} The wall construction for mounting has to be designed for 4 times the weight of the YH8000. Bracket for wall mount can be placed in lengthwise

Sun Shield (Option code: /S)



When the sun shield is mounted, the bracket for wall have to be placed in widthwise.

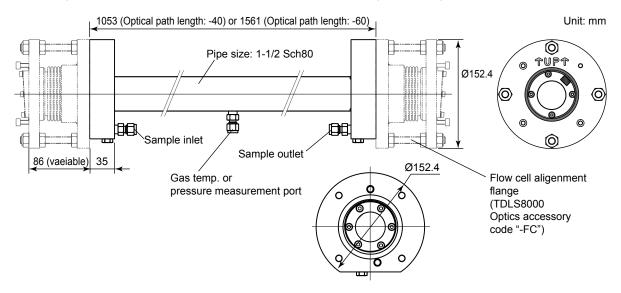
■ IF8000 Isolation Flanges



Process Connection code			lyzer Connection	Hole QTY	Hole	Nut	Hole P.C.D	Thickness	Outside dia.	Bolt length	Purge
	(flange)	(code (flange)	Q	h	Nut	C	t	D	L	port
-21	ANSI CLASS150-2-RF(Eq.)			4	19		120.7	39.6	150	45.7	
-23	ANSI CLASS300-2-RF(Eq.)		ANSI	8	19]	127	39.6	165	50.8	
-31	ANSI CLASS150-3-RF(Eq.)	-21	CLASS150-2-	4	19	5/8UNC	152.4	39.6	190	50.8	1/4NPT
-33	ANSI CLASS300-3-RF(Eq.)		RF(Eq.)	8	22]	168.3	39.6	210	60	
-41	ANSI CLASS150-4-RF(Eq.)			8	19]	190.5	39.1	228.6	50.8	
-50	DIN PN16-DN50-D(Eq.)			4	18		125	41.6	165	50.8	
-80	DIN PN16-DN80-D(Eq.)	-50	DIN PN16-	8	18	M16	160	41.6	200	50.8	Rc1/4
-J5	JIS 10K-50-FF(Eq.)	-50	DN50-D(Eq.)	4	19	IVIIO	120	40.6	165	50.8	KC1/4
-J8	JIS 10K-80-FF(Eq.)		` ''	8	19		150	40.6	185	50.8	

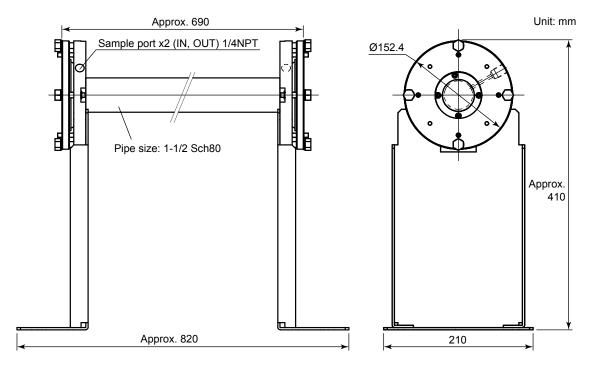
■ YC8000 Flow Cell

TDLS8000 have to be assigned the dedicated Alignment flange (Optic Accessory: -FC). When piping is Rc1/4, a conversion adopter will be attached on the Alignment flange.



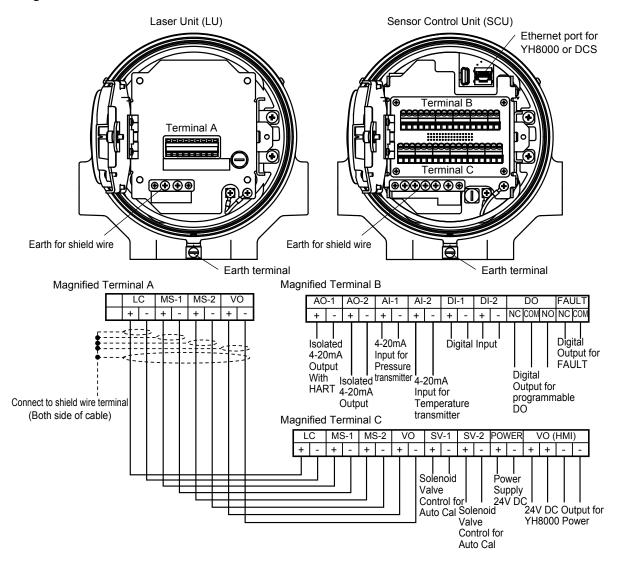
■ Calibration Cell

Part number: K9772XA, K9772XB, K9772XC, K9772XD, K9772XE, K9772XE, K9772XF, K9772XG

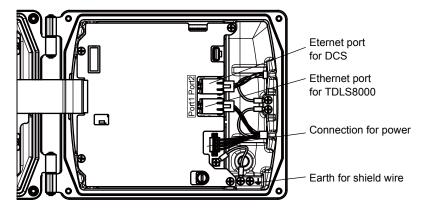


■ WIRING

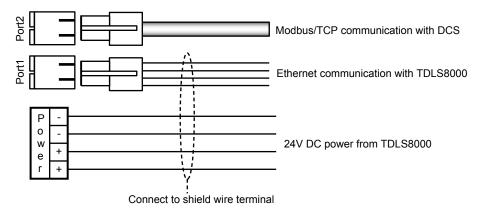
Wiring Laser Unit and Sensor Control Unit



Wiring the YH8000 HMI UNIT

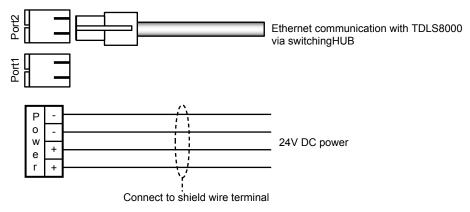


Local HMI configuration



- Connection cable between TDLS8000 and YH8000 must be use special cable which can be specified option code "/C."
- Maximum cable length between TDLS8000 and YH8000 is 3m. Maximum cable length between YH8000 and DCS is 100m.

Remote HMI configuration



Maximum cable length between YH8000 and Switching HUB is 100m.

TDLS8000 Tunable DiodeLase Gas Analyzer Inquiry Form

Thank you for your inquiry about our TDLS8000 Tunable Diode Laser Gas Analyzer. Please make inquiries by placing checkmarks in the appropriate boxes and filling in the blanks. (The items with check mark and descriptions previously filled on the underlines are fixed requirements.)

1.	General Information
	Company :
	Address :
	Contact Person:
	Email :
	Telephone :
	Fax :
	Requested delivery date (day/month/year):
	Plant name :
	Brief Description of application :
2.	Installation Details (check one-see drawing)
۷.	□ Cross Stack/Pipe. For measurement across the process.
	Path length
	Process Connection
	☐ Bypass Leg. Measurement across bypass leg located at process measurement point.
	Path length
	Process Connection
	☐ Extractive. Sample is extracted and transported (by others) to analyzer.
3.	Analyzer Options:
J.	☐ YH8000 HMI Unit ☐ IF8000 Isolation Flanges ☐ YC8000 Flow Cell
	☐ Calibration Cell ☐ Unit Connection Cable
	Cable length from Analyzer Unit to HMI Unit (specify units):
	Area Classification:
	Ambient Temperature (Min-Max.) Specify units
4.	Validation
	□ Not supplied
	☐ Dynamic spiking (incl. valves and controls)
	□ Auto-calibration check (extractive system)
5.	Process Wetted Materials
	Must Use
	Must Not Use

6. Stream Composition (1 sheet per stream analyzed)

Component	Concentrations			Units	Measured	Range	
Name	Min.	Min. Typ. Max.		ppm(v)/vol%	Yes/No	If Measured	

7. Physical Properties

	Units	Min.	Тур.	Max.
Temperature				
Pressure				
Dew Point				
Water Vapor				
Flow				
Velocity				
Particulate Concentration				

Installatio	n location:	☐ Indoo	or 🗆 Outd	loor		
Ambient t	emperature:		to	°C		
General A	pplication	& Installatio	n Notes/Co	mments:		